



PATENT
Attorney Docket No. 29925/39028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jae-Chang Jung et al.

Serial No. 10/619,254

Filed: July 14, 2003

For: Organic Anti-Reflective Coating
Composition And Method For
Forming Photoresist Patterns Using
The Same

Group Art Unit: 1752

Examiner: Richard L. Schilling

) I hereby certify that this paper is being
) deposited with the United States Postal
) Service as first class mail, postage
) prepaid, in an envelope addressed to:
) Mail Stop Amendment, Commissioner
) for Patents, P.O. Box 1450, Alexandria,
) VA 22313-1450 on this date:

) December 12, 2005

) Andrew M. Lawrence
) Andrew M. Lawrence, Reg. No. 46, 130
) Attorney for Applicants

PETITION UNDER 37 C.F.R. § 1.136(a)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants, by their attorney, petition for a one-month extension of time to respond to a final official action dated August 12, 2005.

The Commissioner is authorize to charge our deposit account no. 13-2855 the large entity patent application processing fee of \$120.00.

Any additional required fee may be charged, or any overpayment credited, to our Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

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